Microcoulomb-Class Laser-Plasma Accelerator on OMEGA EP



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Summary

A microcoulomb-class, high-conversion-efficiency laser-plasma accelerator (LPA) was demonstrated on OMEGA EP

- Produced electron beams have:
 - Maximum energies >200 MeV
 - Divergences as low as 32 mrad
 - Charges that exceed 700 nC
 - Laser-to-electron conversion efficiencies up to 11%
- Total charge in the electron beam scales with both a_0 and plasma density





Collaborators

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Motivation

LPAs driven by kJ-class lasers can provide compact sources of high-energy electrons for conversion to photons and positrons





LPA experiments based on self-modulated laser wakefield acceleration (SMLWFA) and direct laser acceleration (DLA) were performed on OMEGA EP





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Electron beams with divergences as low as 32 x 39 mrad were measured



Highest-Charge

• $a_0 = 6.6$

•
$$\Phi_{\text{nozzle}} = 6 \text{ mm}$$



Total charge in the electron beams scales approximately linearly with a₀



10-mm-dia. nozzle at $n_e = 0.2$, 0.5, 1, and 3.5 x 10^{19} cm⁻³



The ideal regime for producing high-charge electron beams for this SMLWFAbased LPA is for $n_e \sim 1 \times 10^{19}$ cm⁻³ or less.



Electron beams with charges up to 707 ± 429/224 nC were measured





Laser-to-electron conversion efficiencies up to 11% were observed



- The weighted average electron energy of the representative electron spectrum from this experiment is 17.9 MeV
- Using this energy, the 707 nC electron beam corresponds to a conversion efficiency from laser energy to electron energy of 11%







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Kochester







- Image plates (IPs) have a known response per electron given the electron energy *,**
- It is therefore straightforward to scan the IPs and retrieve the charge of the incident electron beam
- The photostimulated luminescence (PSL) measured by the second front image plate was integrated and a constant conversion factor was used (0.026 PSL/electron)
- Total measured charge reported was determined within the solid angle of the front image plates
 - For the highest-charge shot only, the EPPS detector was located at a distance of 47.63 cm from target chamber center (solid angle of 26 msr)
 - For the remainder of the shots, the EPPS sat at 56.52 cm (solid angle of 18 msr)
 - The charge in the highest-charge shot contained in the 18 msr aperture is 600 ± 185/162 nC.



^{*} Boutoux, G. *et al.* Rev. Sci. Instrum. **86**, 113304 (2015). ** Tanaka, K. A. *et al.* Rev. Sci. Instrum. **76**, 013507 (2005)

Charge Measurement Technique, Continued.





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- Decay of the PSL signal takes the form of a power distribution PSL = αN^{β}
 - PSL = signal
 - N = number of scans of the image plate.
- Decay of the PSL signal was fit with the power distribution to recover the fit parameters α and β
- Fit parameters from the seven points are averaged to produce an average decay of the signal on the image plate for each scan
- Total signal can then be recovered via the ratio $PSL_{scan1}/PSL_{scanN} = \alpha(1)^{\beta} / \alpha N_{unsat}^{\beta} = 1/N_{unsat}^{\beta}$
 - N_{unsat} = # of scans required to unsaturate IP



